



Enhanced electroluminescence in LXe on thin strips

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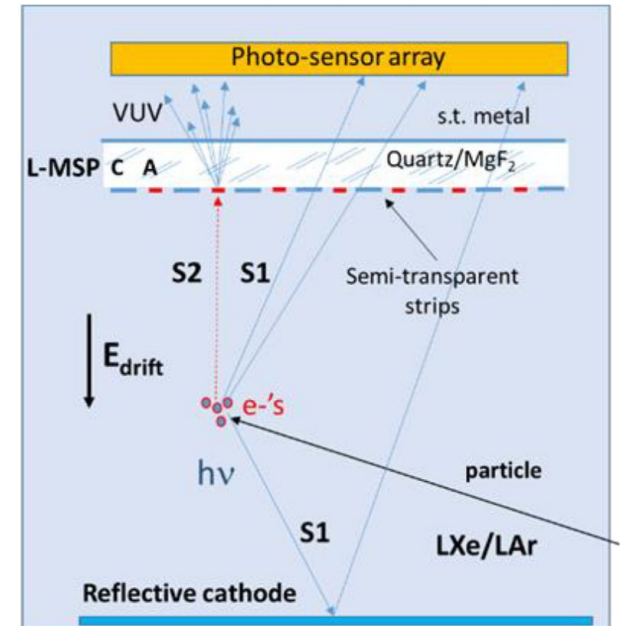
³ University of Coimbra - LIP



Single-phase detectors with EL amplification

- Advantages
 - No liquid-gas interface
 - Reduced instabilities (interface ripples)
 - No delayed e^- emission or e^- transfer inefficiency through interface
 - No gate-interface-anode alignment problems
 - Potential improvement for S2-only events (e.g. lower background)
- Drawbacks
 - Electric fields \sim few 100 kV/cm required for electroluminescence (EL)
 - So far, lower light yield than dual-phase detectors

[Breskin 2023](#)



Single phase concept based on microstrips

EL amplification in noble liquids

- Thin wires

- Simple
- Challenges in upscaling
 - Wire tensioning
 - Difficult to deploy long wires
 - Wire staggering under high fields

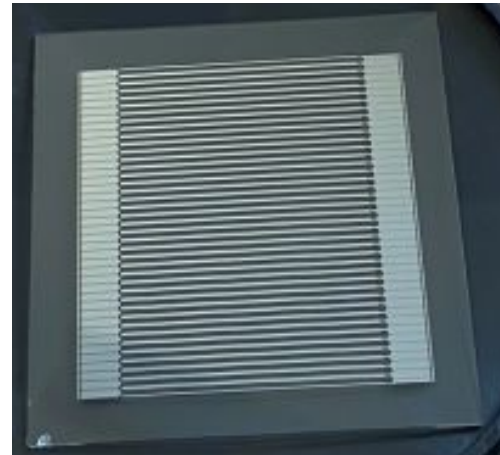
[Tönnies et al](#)



- Microstrips

- Mechanically more robust
- Modular
- Instabilities due to insulating substrate?
- VUV transparency still to be worked out

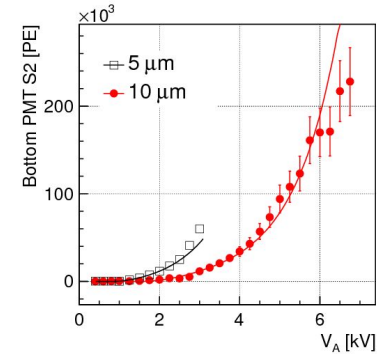
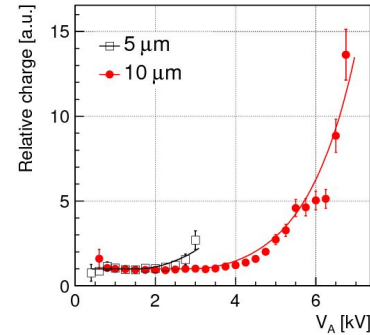
[Martinez-Lema et al](#)



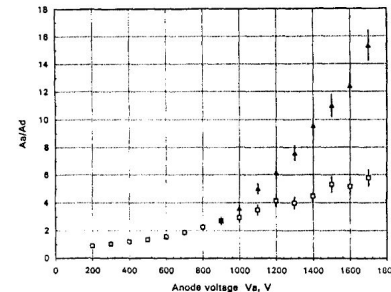
EL amplification in LXe

- Thresholds
 - Charge multiplication ~ 725 kV/cm [Aprile et al](#)
 - Electroluminescence ~ 412 kV/cm [Aprile et al](#)
 - Microstrips measurements in agreement [Martinez-Lema et al](#)
- Thin wires (5-25 μm)
 - ~ 290 photons/ie, $\sim x14$ charge gain @ 6.75 kV [Aprile et al](#)
 - 17 photons/ie @ 3.6 kV & single electron sensitivity [Qi et al](#)
 - 29 photons/ie @ 4.4 kV [Tönnies et al](#)
- Microstrips
 - $\sim x10$ e^- multiplication @ 1.7 kV [Policarpo et al](#)
 - ~ 33 photons/ie @ 2 kV [Martinez-Lema et al](#)

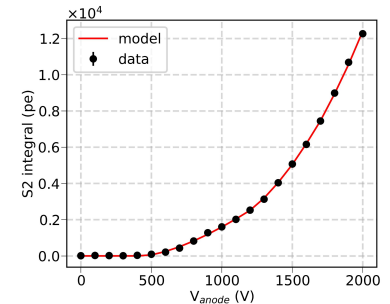
[Aprile et al](#)



[Policarpo et al](#)

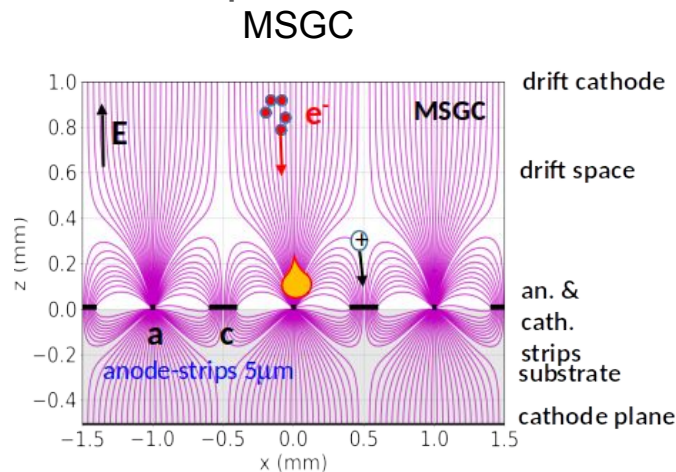
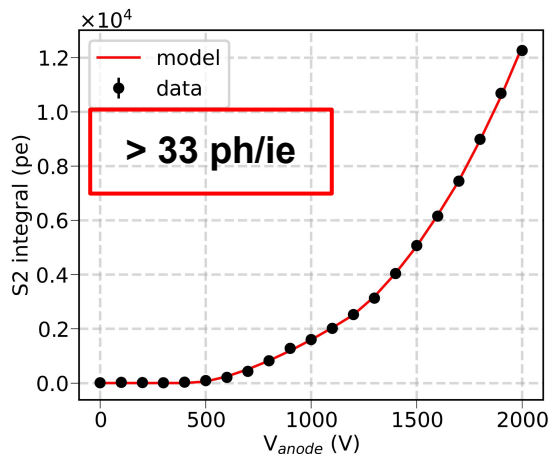


[Martinez-Lema et al](#)



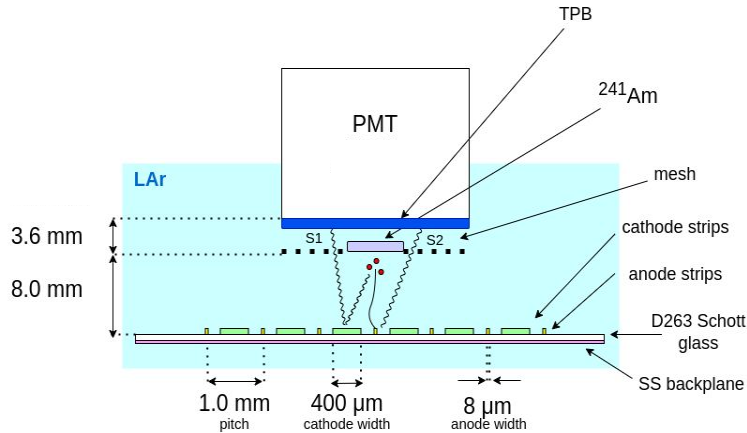
LIDINE-2023: EL amplification on MSGC

- MSGC: wide (400 μm) cathode interleaved with narrow (8 μm) anode strips with 1 mm pitch on glass
- ≥ 33 photons/electron at strips $\Delta V = 2$ kV, $\sim x3$ e^- multiplication

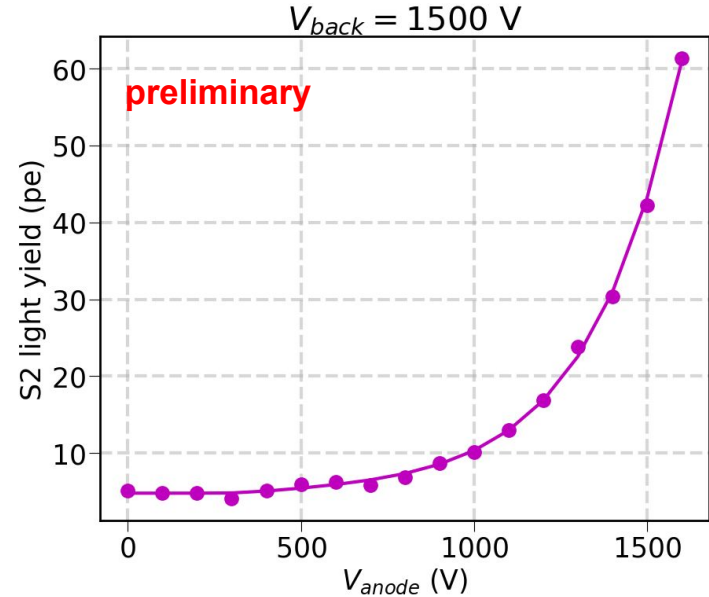


Microstrips in LAr (preliminary)

- Same geometry as in LXe
- Lower light yield than LXe (~ 1 ph/ie)
- EL threshold ~ 350 - 600 kV/cm
- CM threshold ~ 430 - 650 kV/cm



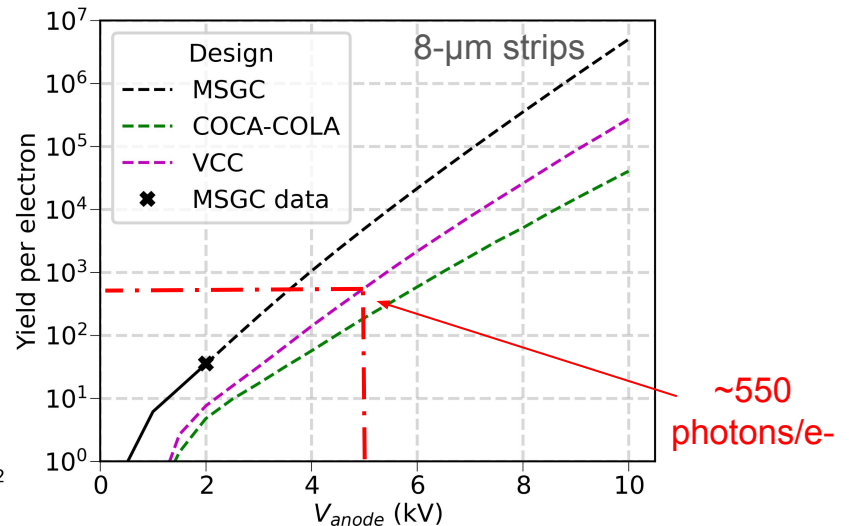
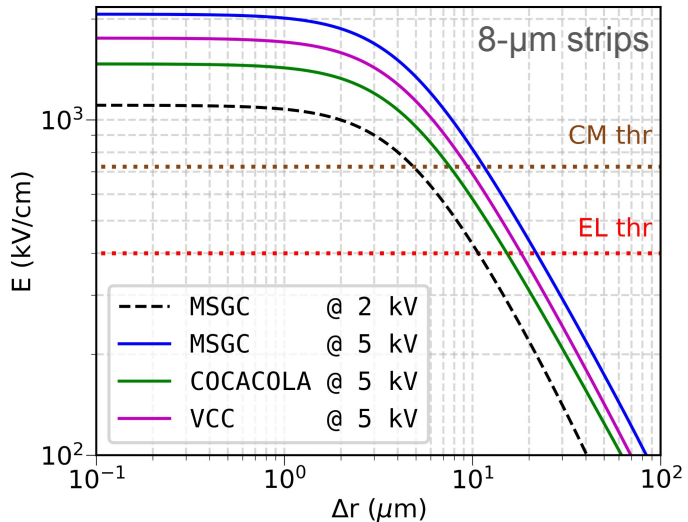
Not presented
in LIDINE 2023!



paper in preparation

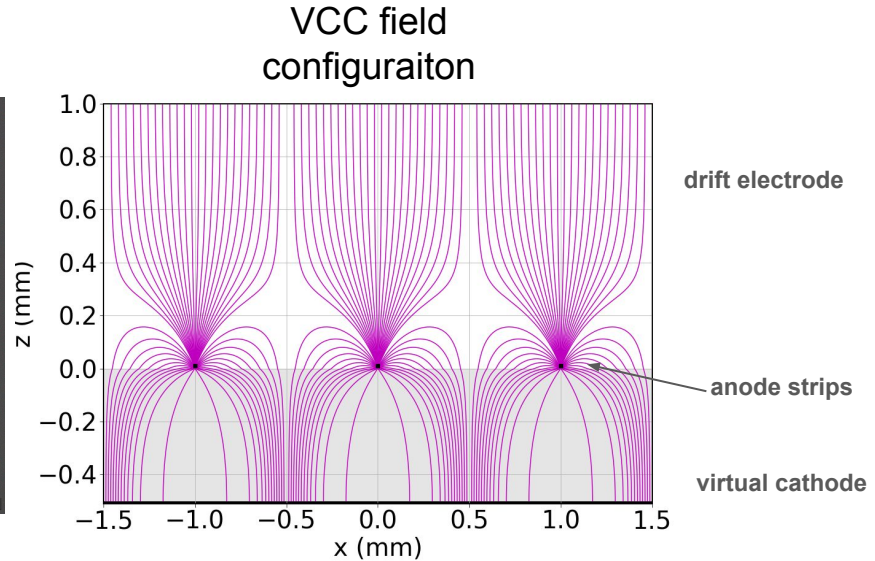
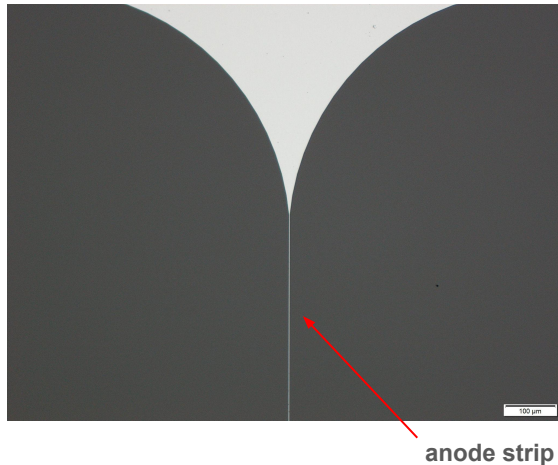
Prospects of different MSP geometries

- MSGC operation is limited by discharges between anode and cathode strips
 - Other geometries can enhance light yield
 - COMSOL-based extrapolations predict much higher light yields for $\Delta V = 5$ kV (unreachable with MSGC)

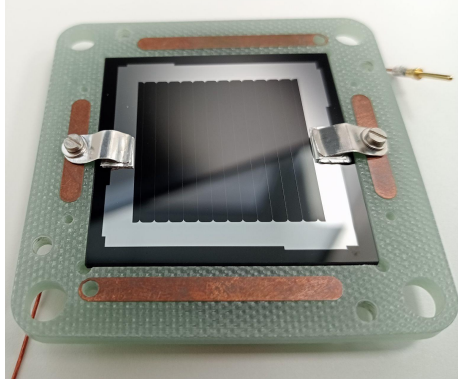


Virtual Cathode Chamber (VCC) design

- Thin anode strips on top face
- Thin conductive layer on the bottom face
- Higher applicable potentials
- First proposed by [Capeans et al](#)



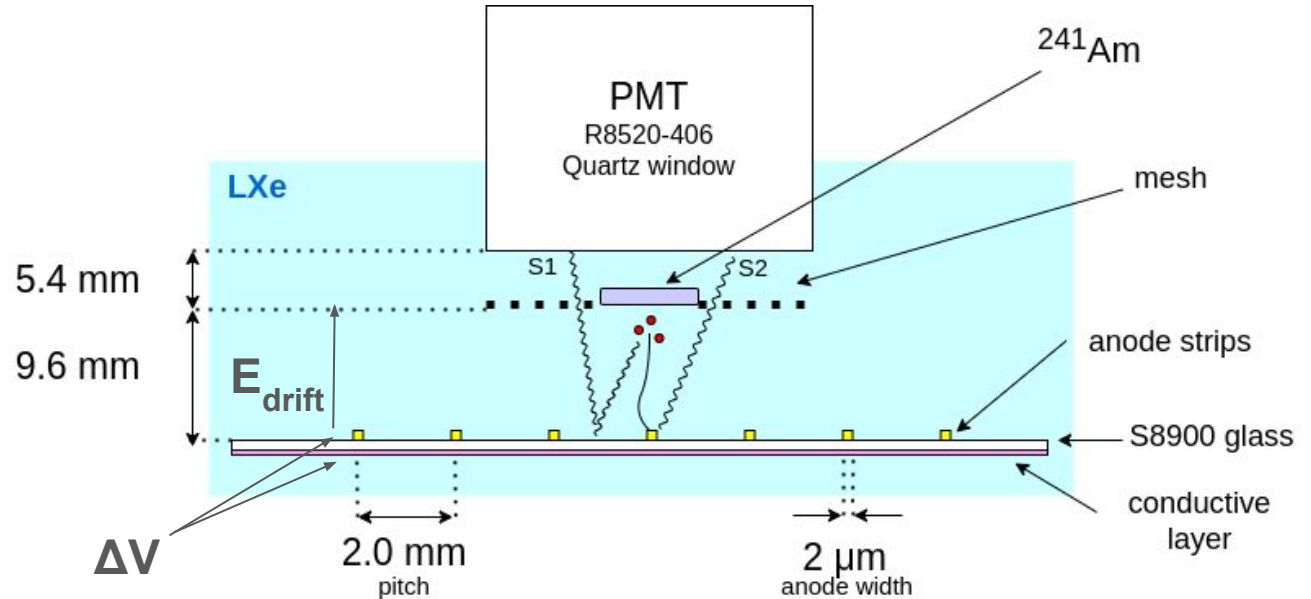
Our setup



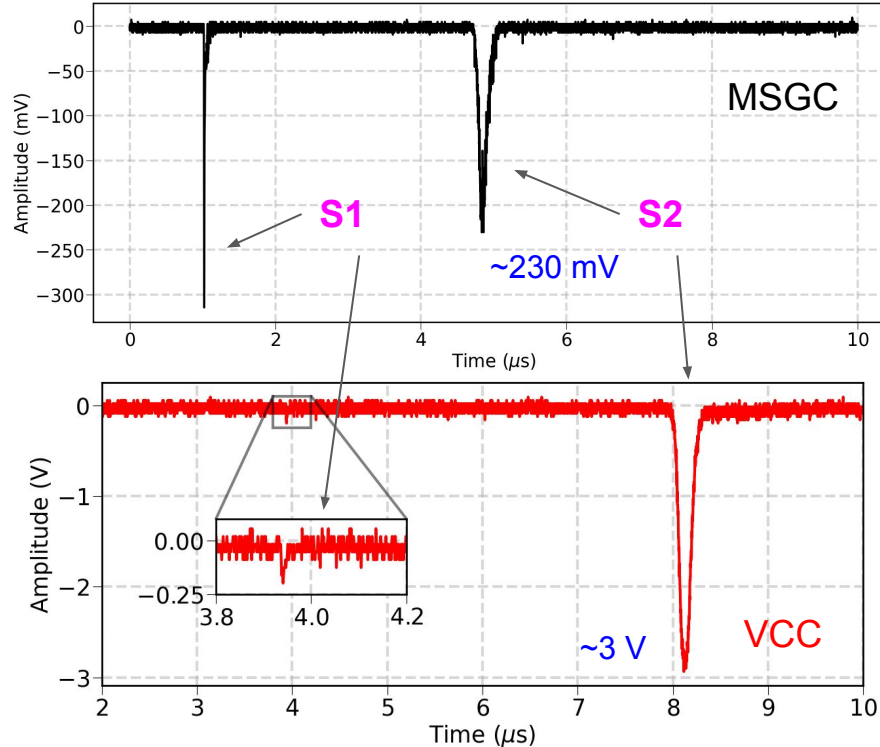
Our plate

- 2- μm -wide anode strips, 130 nm thick
- 1.5-mm-thick substrate
- S8900 semiconductive glass*

*previously used in MSGC



Typical PMT waveforms



$V_{\text{source}} = -2.0 \text{ kV}$
 $V_{\text{cathode}} = \text{ground}$
 $V_{\text{back}} = -2.0 \text{ kV}$
 $V_{\text{anode}} = +1.6 \text{ kV}$
 $\Delta V = 1.6 \text{ kV}$

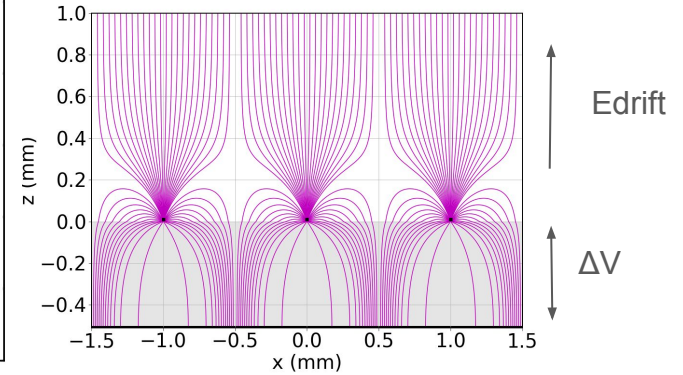
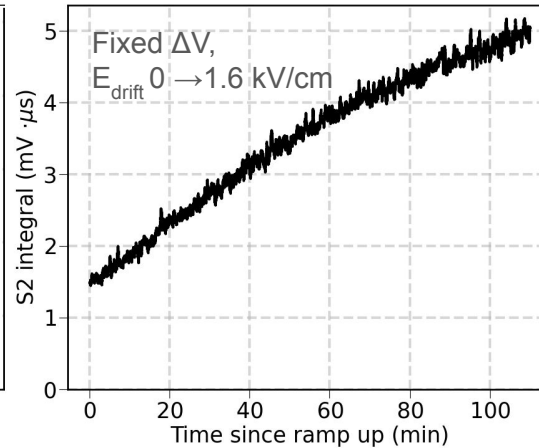
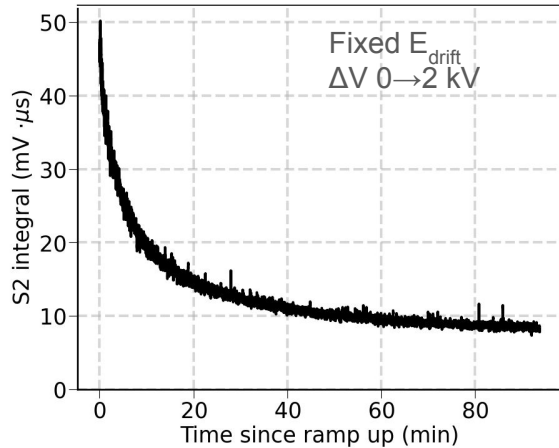
$V_{\text{source}} = -2.0 \text{ kV}$
 $V_{\text{back}} = -1.75 \text{ kV}$
 $V_{\text{anode}} = +3.25 \text{ kV}$
 $\Delta V = 5.0 \text{ kV}$

$$\Delta V = V_{\text{anode}} - V_{\text{back}}$$

Substrate charge up/polarization

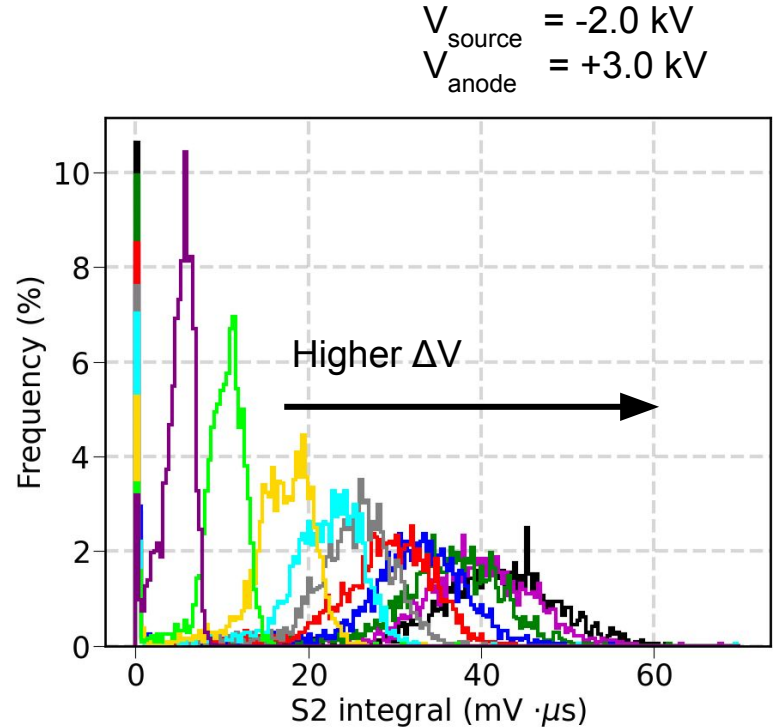
[under review!](#)

- Strong reduction of S2 yield over time
- Stable photoyield only after several hours
- Possible interpretations:
 - Polarization of the substrate
 - Charging up of the surface unlikely: very low source rate & very low charge multiplication



Light yield vs voltage

- PMT waveform integrated on a fixed time window
- Converted to PE based on an in-situ PMT calibration
- S2 integral increases with ΔV
- **EL threshold @ $\Delta V \sim 200$ V**



Light yield vs voltage

- Measurements taken with a fixed few min delay between data points to reduce time-dependence
- Light yield @ $\Delta V = 5$ kV, close to saturation:

~30 photons/e⁻

Experimental parameters

$\Omega/4\pi \sim 7.9 \%$

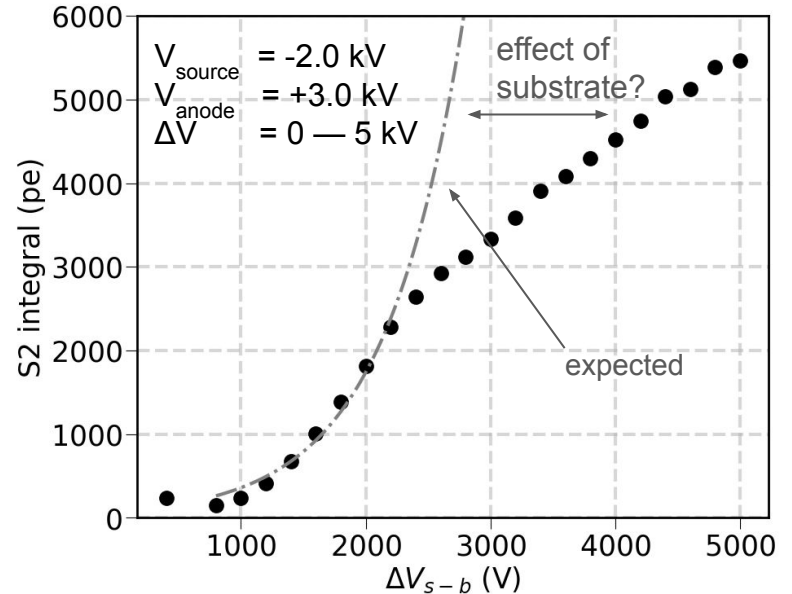
$T \sim 81\%$

$QE \sim 28\%$

$N_{ie} \sim 10500$

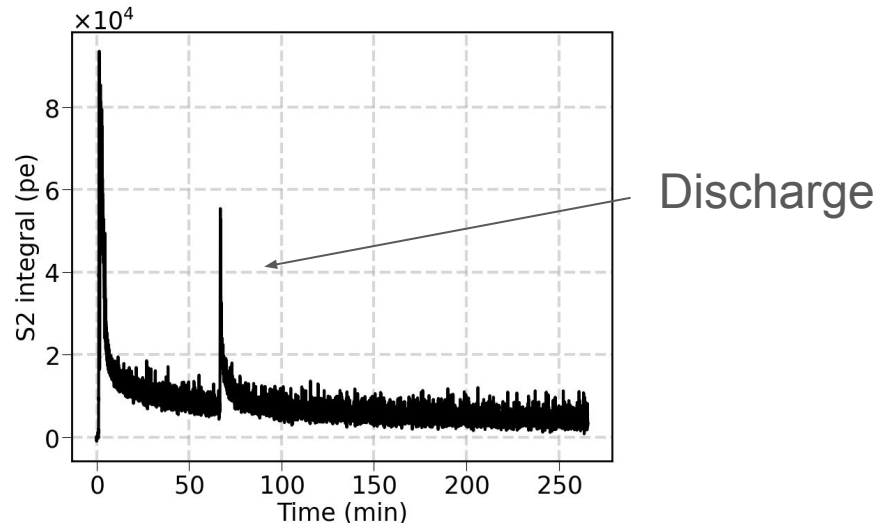
$$LY = \frac{S2}{\frac{\Omega}{4\pi} \cdot T \cdot QE_{PMT} \cdot N_{ie}}$$

← mesh transparency
← from alpha particles



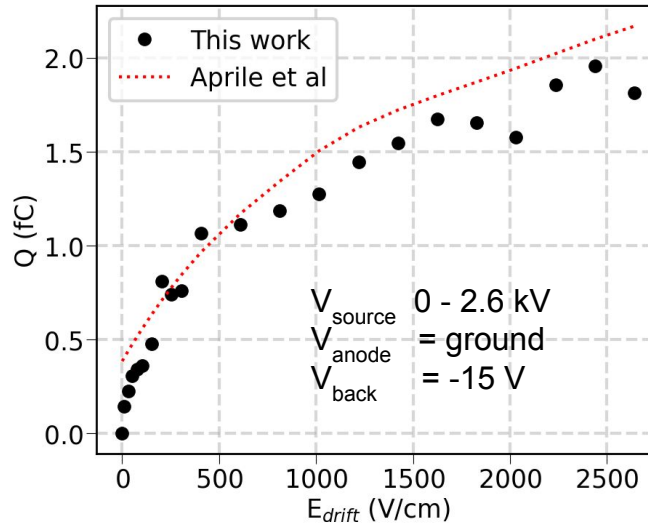
Maximum light yield

- Observe S2 as a function of time for $\Delta V = 5 \text{ kV}$
- Maximum initial S2 $\sim 9.3 \cdot 10^4$ photons $\rightarrow \sim 500$ photons/electron
- Different substrate might results in a stable high light yield



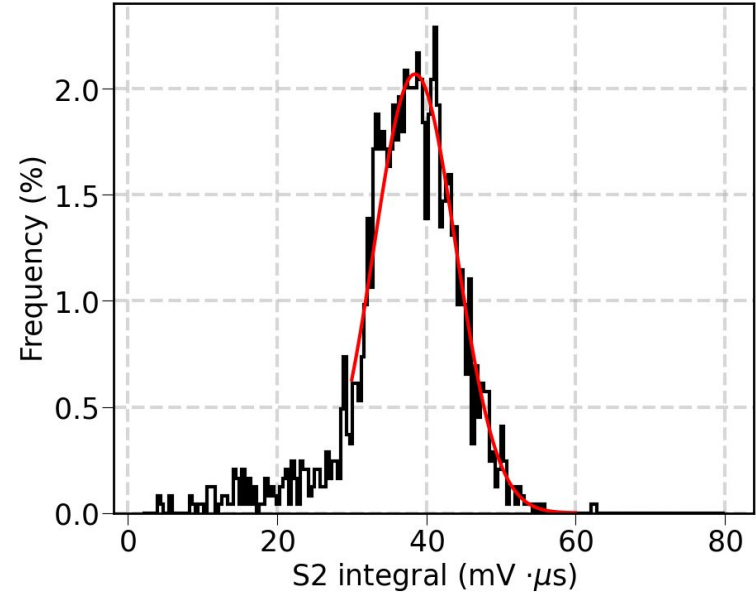
Charge

- Parallel plate configuration (no field across plate)
- Charge sensitive preamp on strips
- In agreement with [Aprile et al](#)
- Other charge measurements in progress



Preliminary energy resolution

- Gaussian fit to the S2 integral spectra
- $\sigma/\mu \sim 14\%$ @ $\Delta V = 5$ kV
- Affected by time variations of S2 yield
- Potential to improve with different substrate



Summary

- Single-phase detectors → solutions to problems faced by dual-phase TPCs
- Microstrip plates → EL & CM in liquid with some charge and high light yields
- Former light yield measurement in LXe potentially improved using a VCC design
 - up to **~500 photons/electron** before substrate chargeup/polarization
 - **~30 photons/electron** in more stable conditions (VCC) vs 33 photons/electron (MSGC)
 - Performance severely compromised by the choice of substrate
 - Charge multiplication yields still under study
- Other substrates must be studied to improve stability
 - Quartz or MgF₂ needed for high UV transparency
 - Lower resistivity ion glass vs electronic glass?
 - Could surface resistivity be lowered by surface treatment (e.g. ion implantation)? Experts needed!

Paper in preparation!

Acknowledgements

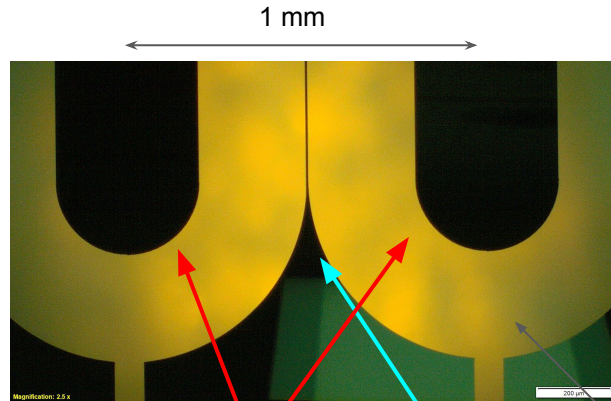
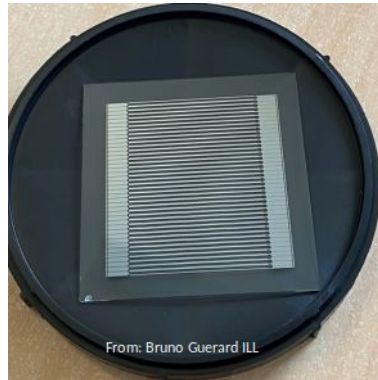
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- GML thanks Dr. Lior Arazi of the Unit of Nuclear Engineering at Ben Gurion University & VC thanks the Physics Faculty of Weizmann Institute, for their support.

Thank you for your attention

Backup

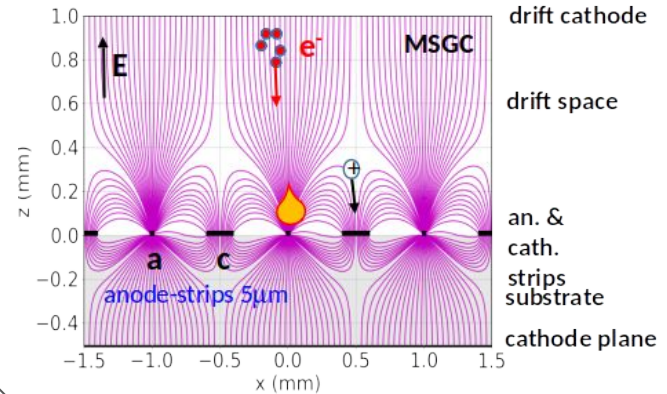
Microstrips

- First proposed by [A. Oed](#) in 1988 for the MicroStrip Gas Chamber (MSGC)
- Thin strips deposited on a substrate (ideally VUV-transparent)
- Original design: cathode and anode strips interleaved



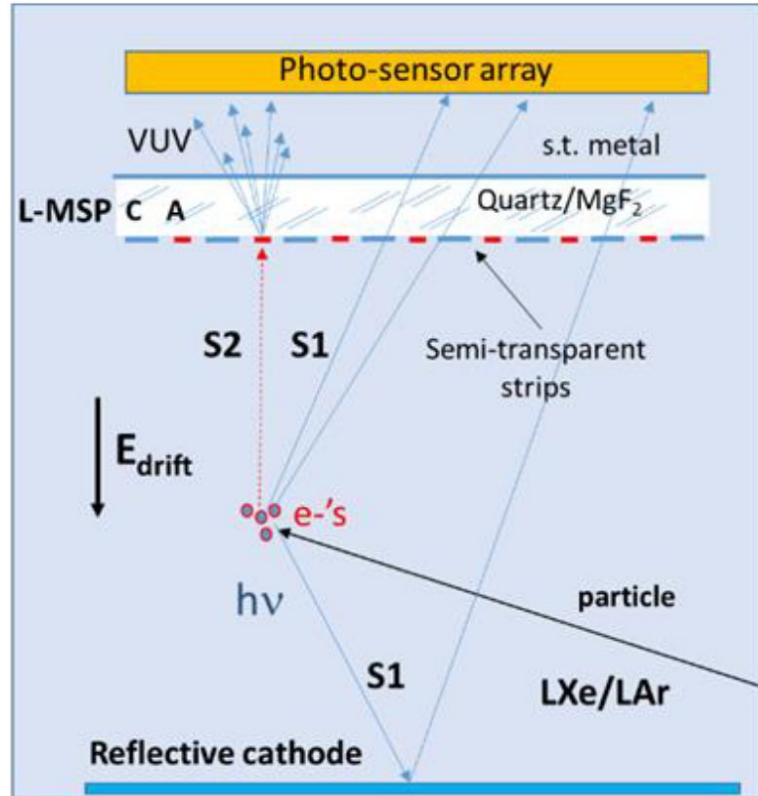
cathode strips

anode strip



light seen through the substrate

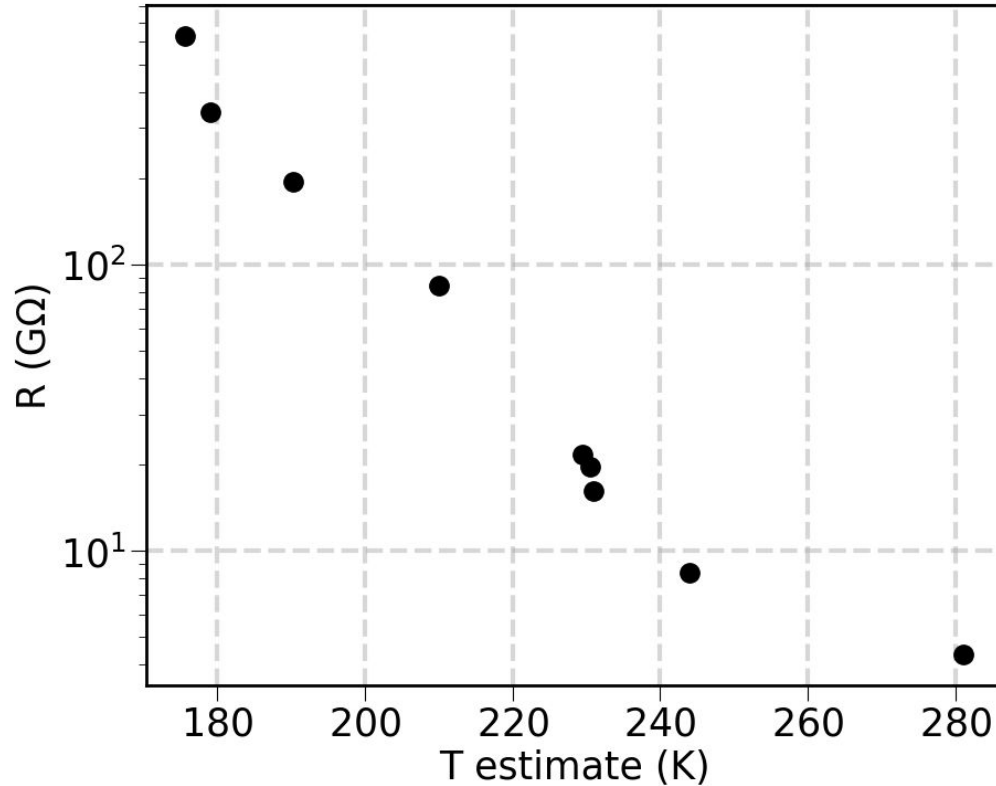
Single phase concept with Microstrips



[Breskin 2023](#)

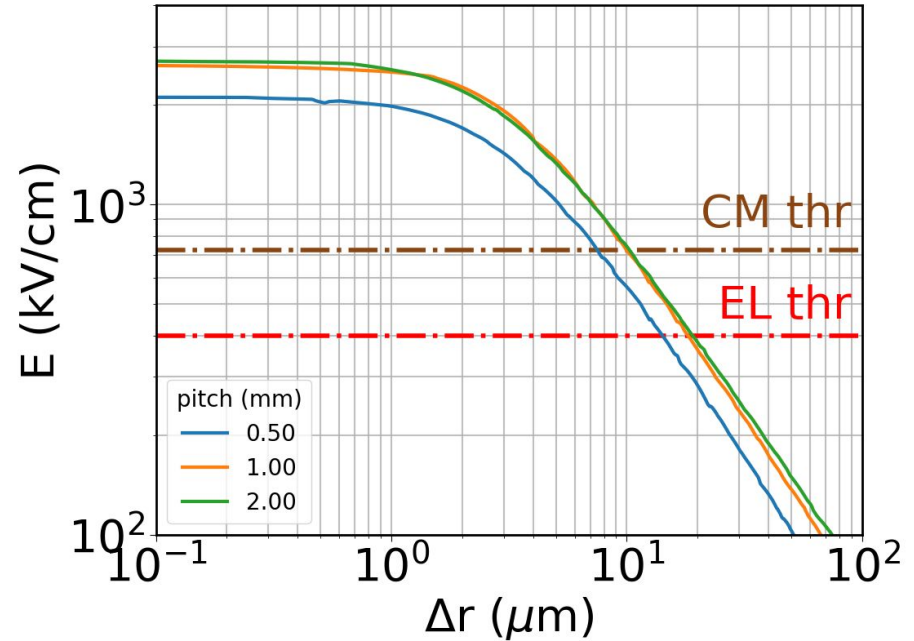
Substrate resistivity vs T

Temperature
measured
during
detector
cooldown

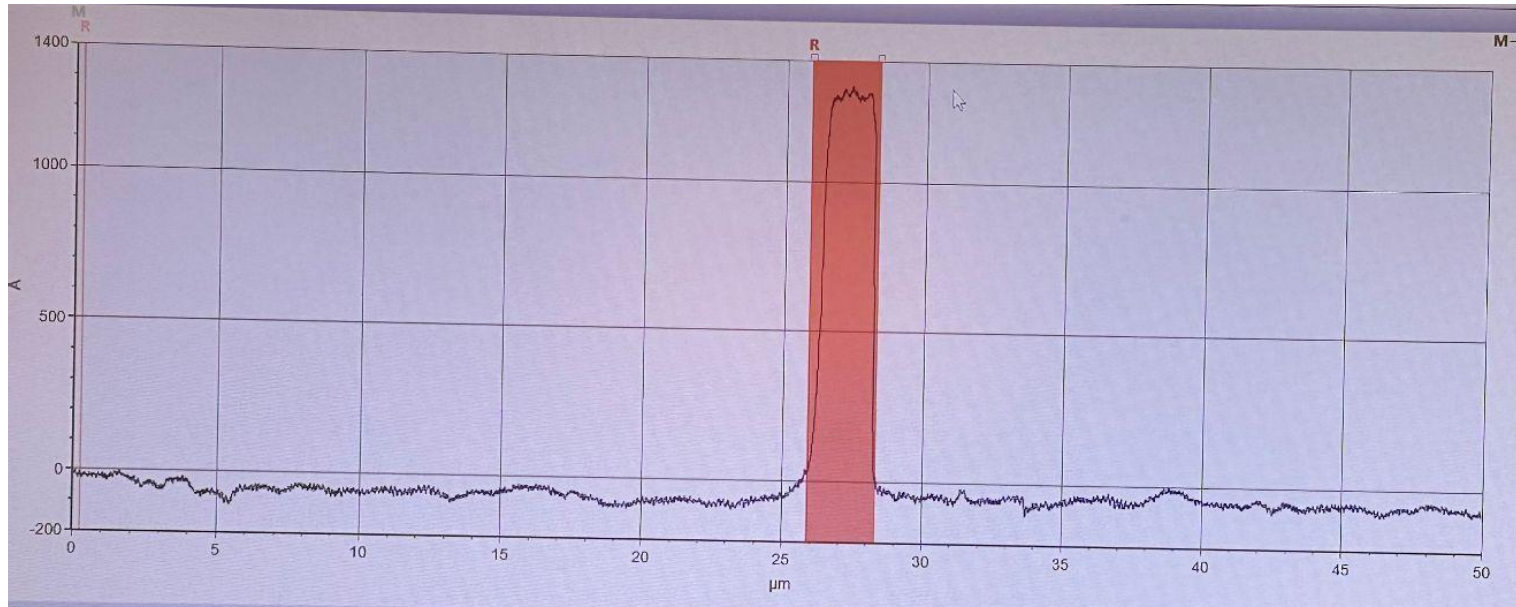


Geometry optimization

- Current geometry
 - 2 mm pitch
 - 2 μm strip width
 - 1.5 mm substrate thickness
 - Semiconductive glass
- Possible optimizations
 - 1 mm pitch \rightarrow same field, less insulating area
 - Different substrate



Strip profile



EL & CM model

Aprile et al

$$\left\{ \begin{array}{l} \frac{dN_e}{dx} = N_e(x) \cdot \theta_0 \cdot e^{-\frac{\theta_1}{E(x) - \theta_2}} \\ \frac{dN_\gamma}{dx} = N_e(x) \cdot \theta_3 \cdot (E(x) - \theta_4) \end{array} \right.$$

θ_{0-4} model parameters

E(x) from COMSOL